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(54) **POLYMER PIEZOELECTRIC FILM  
ELEMENT, POWER STORAGE DEVICE  
USING SAME, AND LOAD DETECTION  
DEVICE**

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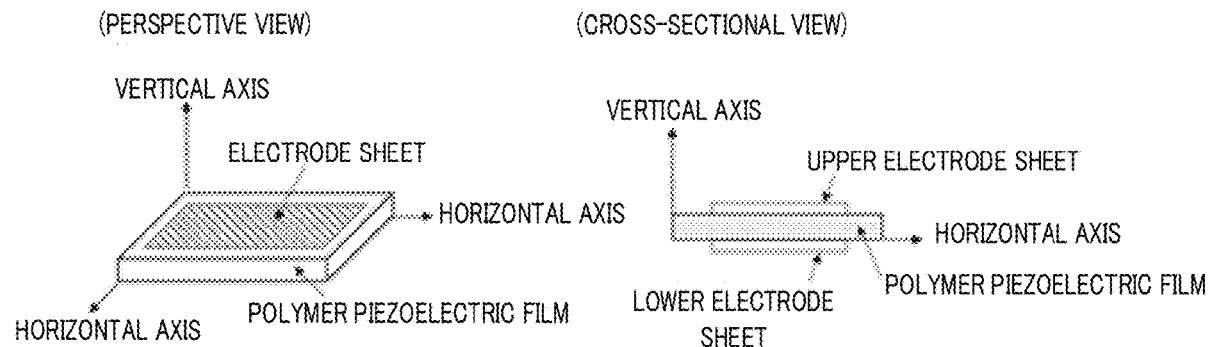
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**ABSTRACT**

Provided is a polymer piezoelectric film element which generates electricity at a high sensitivity upon vibrations across a broad frequency band, including those caused by the motion of humans or animals or faint contact stress, and those caused by automobiles and so on, which can be made into a thin film and at a high yield, and which can be used as a stably driving power supply device, a tactile sensor, or a vital sensor. The present invention pertains to: a polymer piezoelectric film element characterized in that an electrode sheet is formed on both surfaces of a polymer piezoelectric film, and by having a structure which has bumps and dips or a wave-shaped structure which has peaks and valleys in an axis perpendicular to said surfaces; and a power storage device, a sensor, or a vital sensor.

ELECTRODE SHEETS ARE FORMED ON BOTH SURFACES OF POLYMER PIEZOELECTRIC FILM



POLYMER PIEZOELECTRIC FILM HAS RECESS-PROTRUSION STRUCTURE OR CREST-TROUGH CORRUGATED STRUCTURE IN VERTICAL AXIS TO SURFACES

